

MAY 06 2005

PATENT

Atty Docket No.: 10004808-1

## In The U.S. Patent and Trademark Office

## In Re the Application of:

**Inventor(s):** Osamu S. Nakagawa      **Confirmation No.:** 3635  
**Serial No.:** 09/891,324      **Examiner:** Schillinger, Laura M.  
**Filed:** June 27, 2001      **Group Art Unit:** 2813  
**Title:** PROCESS FOR HIGH-DIELECTRIC CONSTANT METAL-INSULATOR  
METAL CAPACITOR IN VLSI MULTI-LEVEL METALIZATION SYSTEMS

## MAIL STOP AF

Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

## CERTIFICATE OF FACSIMILE TO THE USPTO

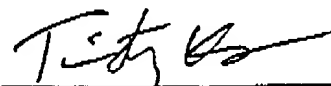
I hereby certify that this correspondence is being transmitted to the Patent and Trademark Office facsimile number (703) 872-9306 on May 6, 2005. This correspondence contains the following document(s):

1 sheet of Transmittal Letter for Response/Amendment. (2 copies).  
16 sheets of Request for Reconsideration.

Respectfully submitted,

MANNAVA &amp; KANG, P.C.

On May 6, 2005



Timothy B. Kang  
Reg. No.: 46,423

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P. O. Box 272400  
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PATENT APPLICATION

ATTORNEY DOCKET NO. 10004808-1

IN THE  
UNITED STATES PATENT AND TRADEMARK OFFICE

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TRANSMITTAL LETTER FOR RESPONSE/AMENDMENT

Sir:

Transmitted herewith is/are the following in the above-identified application:

- (X) Response/Amendment ( ) Petition to extend time to respond  
( ) New fee as calculated below ( ) Supplemental Declaration  
(X) No additional fee  
( ) Other: \_\_\_\_\_ (fee \$ \_\_\_\_\_)

CLAIMS AS AMENDED BY OTHER THAN A SMALL ENTITY						
(1) FOR	(2) CLAIMS REMAINING AFTER AMENDMENT	(3) NUMBER EXTRA	(4) HIGHEST NUMBER PREVIOUSLY PAID FOR	(5) PRESENT EXTRA	(6) RATE	(7) ADDITIONAL FEES
TOTAL CLAIMS	13	MINUS	20	= 0	X \$50	\$ 0
INDEP. CLAIMS	1	MINUS	3	= 0	X \$200	\$ 0
[ ] FIRST PRESENTATION OF A MULTIPLE DEPENDENT CLAIM					+ \$360	\$ 0
EXTENSION FEE	1ST MONTH \$120.00	2ND MONTH \$450.00	3RD MONTH \$1020.00	4TH MONTH \$1590.00		\$ 0
OTHER FEES						\$
TOTAL ADDITIONAL FEE FOR THIS AMENDMENT						\$ 0

Charge \$ 0 to Deposit Account 08-2025. At any time during the pendency of this application, please charge any fees required or credit any overpayment to Deposit Account 08-2025 pursuant to 37 CFR 1.25. Additionally please charge any fees to Deposit Account 08-2025 under 37 CFR 1.16, 1.17, 1.19, 1.20 and 1.21. A duplicate copy of this sheet is enclosed.

Respectfully submitted,

Osamu S. Nakagawa

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Number of pages: 19

Typed Name: Judy H. Chung

Signature: By 

Timothy B. Kang

Attorney/Agent for Applicant(s)

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P. O. Box 272400  
Fort Collins, Colorado 80527-2400

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Typed Name: Judy H. Chung

Signature: Judy H. ChungBy Timothy B. Kang

Timothy B. Kang

Attorney/Agent for Applicant(s)  
Reg. No. 46,423

Date: May 6, 2005

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**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE****Inventor(s):** Osamu S. Nakagawa**Confirmation No.:** 3635**Serial No.:** 09/891,324**Examiner:** Schillinger, Laura M.**Filed:** June 27, 2001**Group Art Unit:** 2813**Title:** PROCESS FOR HIGH-DIELECTRIC CONSTANT METAL-INSULATOR  
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**REQUEST FOR RECONSIDERATION**

Sir:

Applicant respectfully submits this Request for Reconsideration in response to the Final Official Action mailed on March 8, 2005. Please find below a listing of all the pending claims for the convenience of the Examiner in considering this Request for Reconsideration. The Examiner is respectfully requested to consider the remarks following the listing of the pending claims.